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Photoelectric current measurement of plasma grid materials for a compact H⁻ ion source

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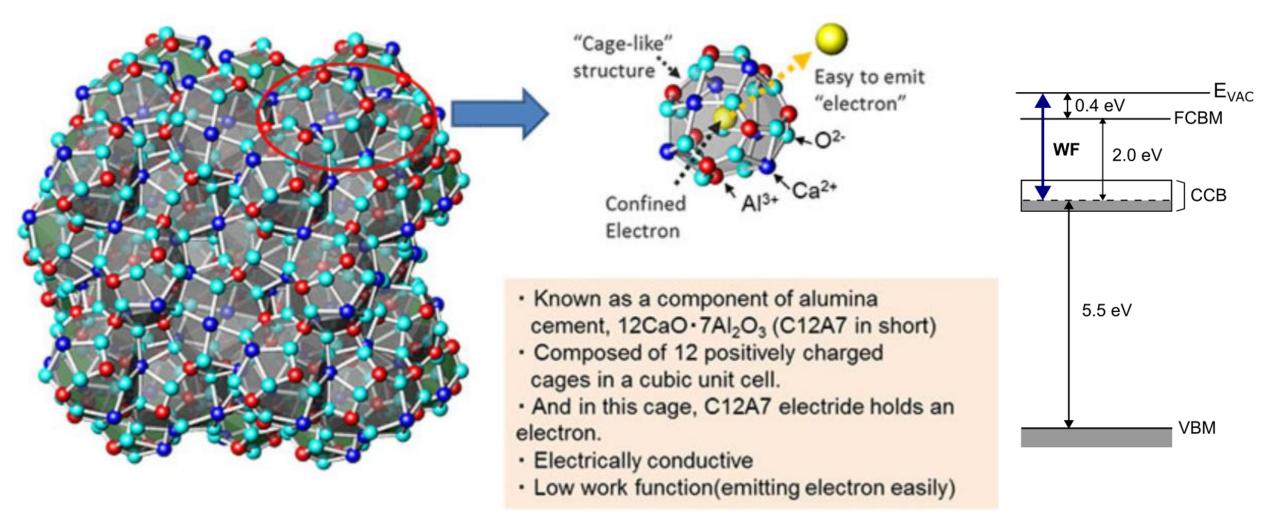
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The authors would like to thank H. Hosono for the permission to use C12A7electride. The C12A7-electride was supplied from AGC inc., and technical support by Naomichi Miyakawa, Satoru Watanabe, and Kazuhiro Ito of AGC Inc. This work was supported by Grant-in-Aid for Scientific Research of JSPS, 19H01883, 17H03512.

- Electride as a Cs free PG material
- Requirements as the PG material
 - >High negative ion production probability (low work function)
 - ≻Low material emission
 - Long life in hydrogen/deuterium plasmas
- Purpose of the PG surface diagnostics
- Experimental setup
- Results
 - LED based photoelectric current measurement
 - Change of surface condition by hydrogen plasma exposure
- Summary and outlook

Electride as a Cs-free PG material



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Requirements as the PG material

• A PG material should satisfy the following requirements:

High negative ion yield for the surface collisions and desorption of hydrogen/deuterium atoms and ions.

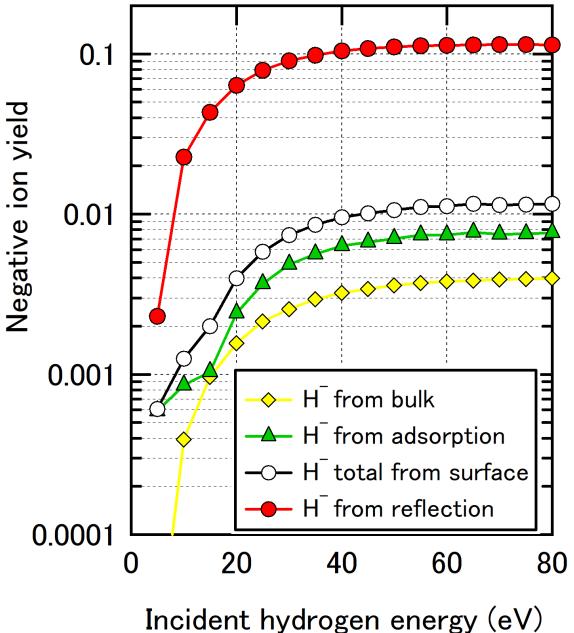
Robustness against hydrogen/deuterium plasma exposure.

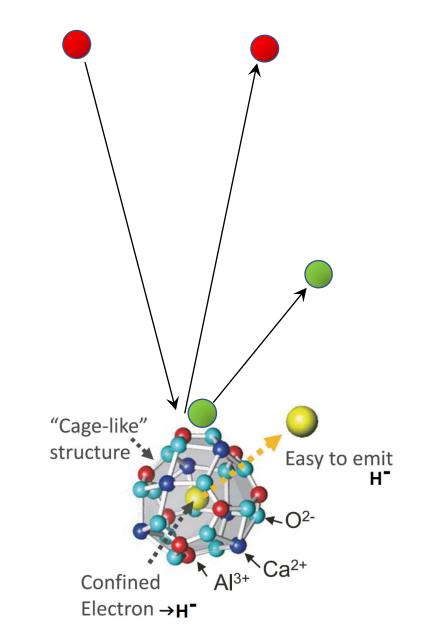
>Low impurity emission to the hydrogen/deuterium plasmas.

• These characteristics can be evaluated using plasma-surface interaction model.

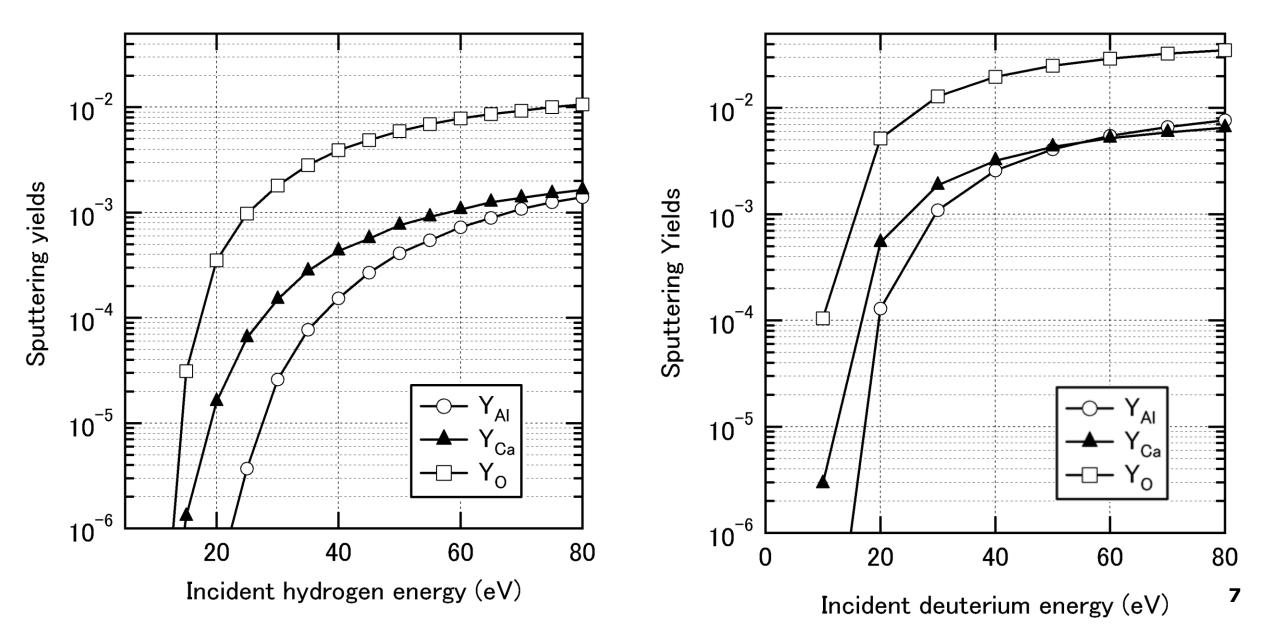
ACAT simulations were done for the corresponding conditions for hydrogen/deuterium plasmas.

Three components: two from surface





Deuterium erodes electride PG



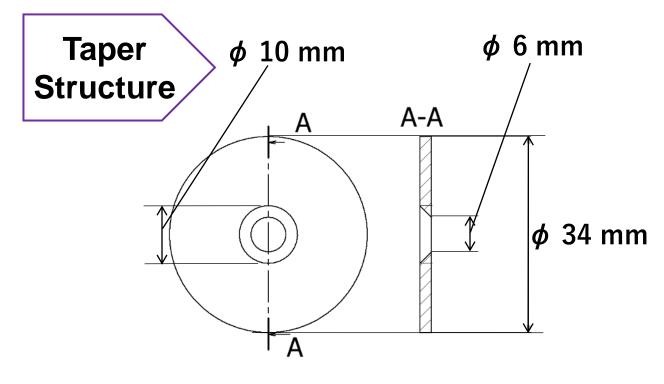
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Purpose of the PG surface diagnostics

- For long term usage of bulk electride PG, deterioration due to long term plasma exposure: impurity accumulation/removal of surface cage structure, must be monitored.
- The PG surface layer can be renewed after confirming the depletion of the electride deposition. (Electride PG can be prepared by through sputtering process.)
- Both operations requires proper time for the PG surface treatment.
- Thus, we need to monitor the electride PG surface condition.

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Experimental setup – Plasma grid



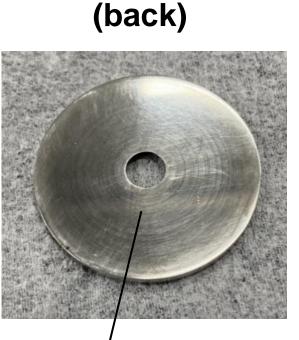
Hole diameter : Φ4mm, 6mm Thickness : 2mm Material diameter : Φ34mm

C12A7 electride

Plasma grid

(front)

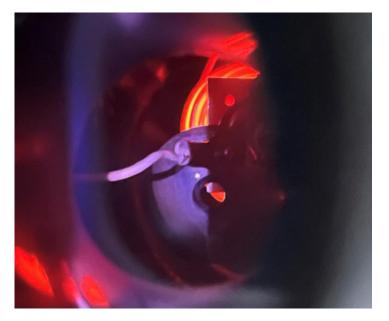
Molybdenum



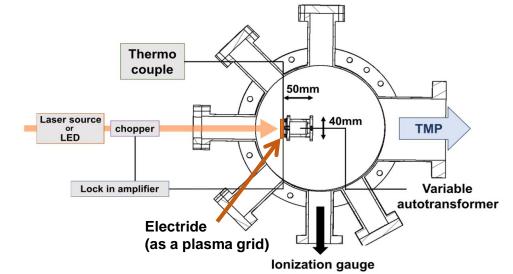
Plasma grid

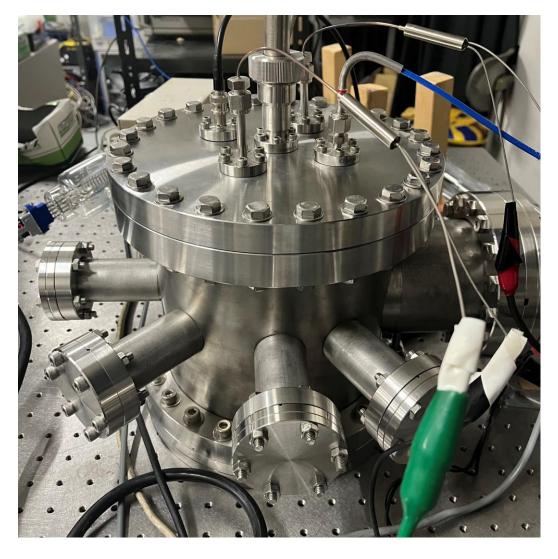
Experimental setup –Electride heating system Heater : Nichrome exotherm SUS sheath Thermocouple : K type Thermo 0 0 SUS sheath couple Heater base : Mo 50mm Holder : SUS Laser source 40mm TMP chopper or LED Variable Lock in amplifier 0 autotransformer Remove the surface layer Electride by heating the sample up. (as a plasma grid) **Ionization** gauge

Experimental setup -Electride heating system

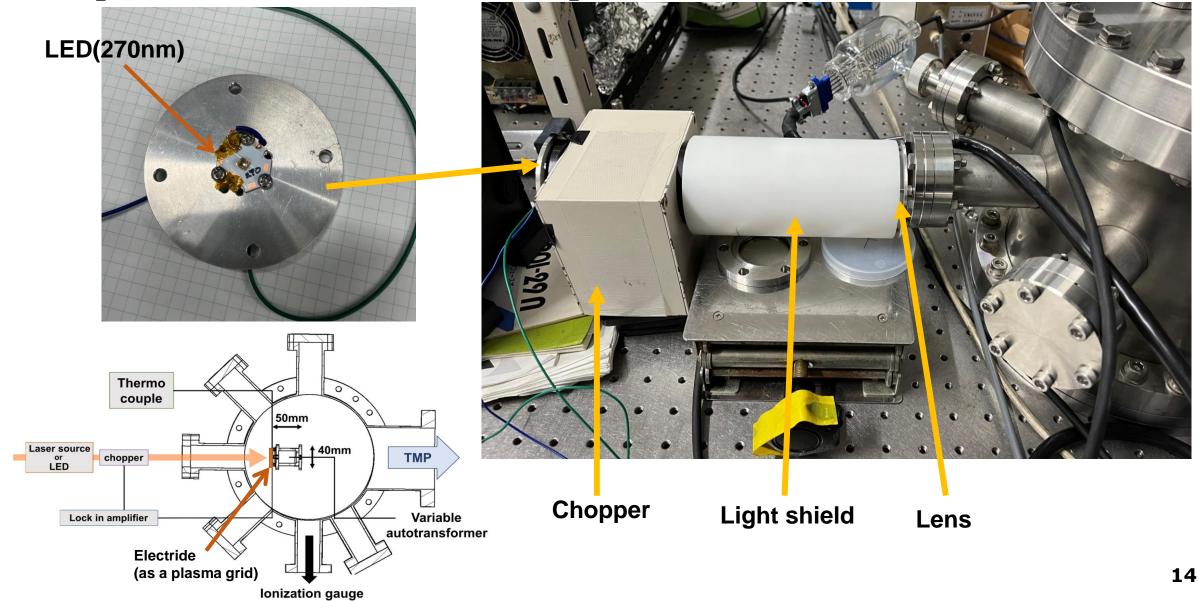




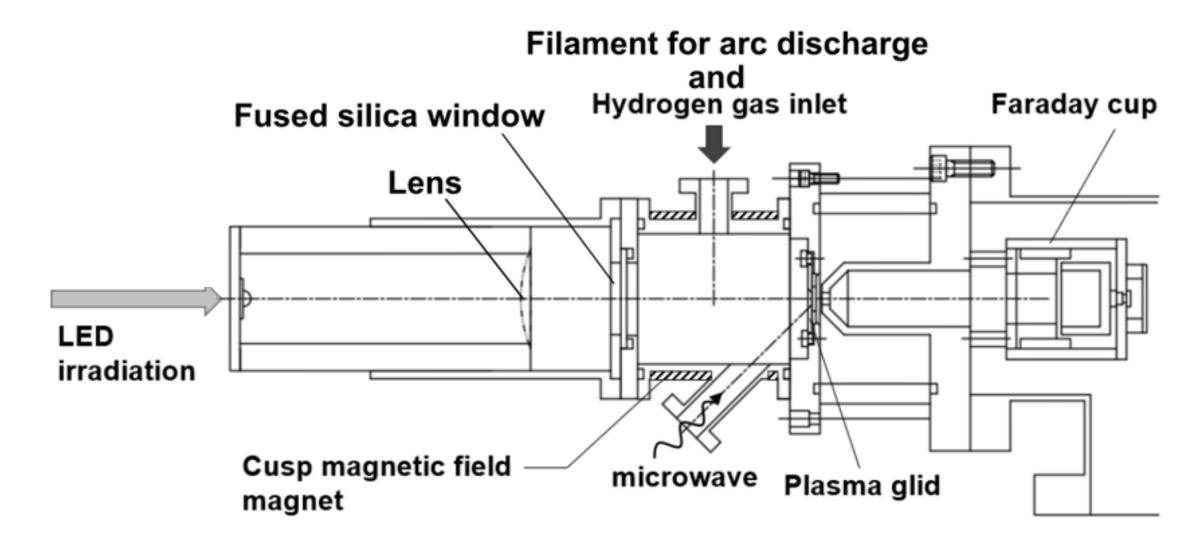




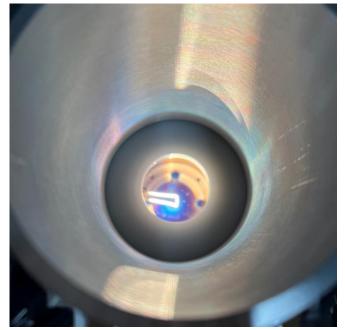
Experimental setup –Electride heating system

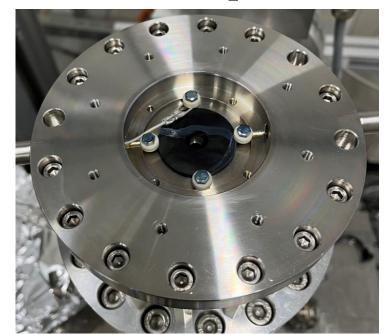


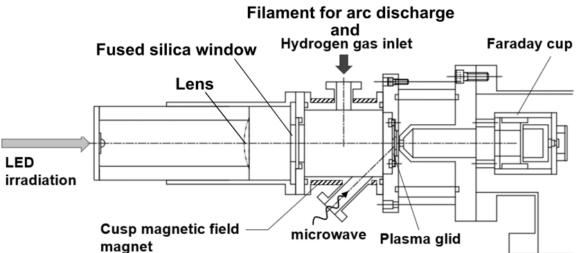
Experimental setup -ion source

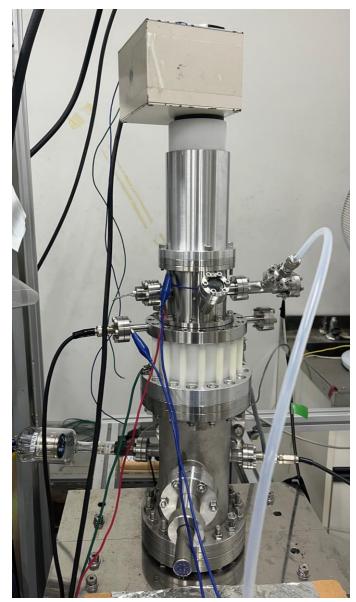


Experimental setup -ion source





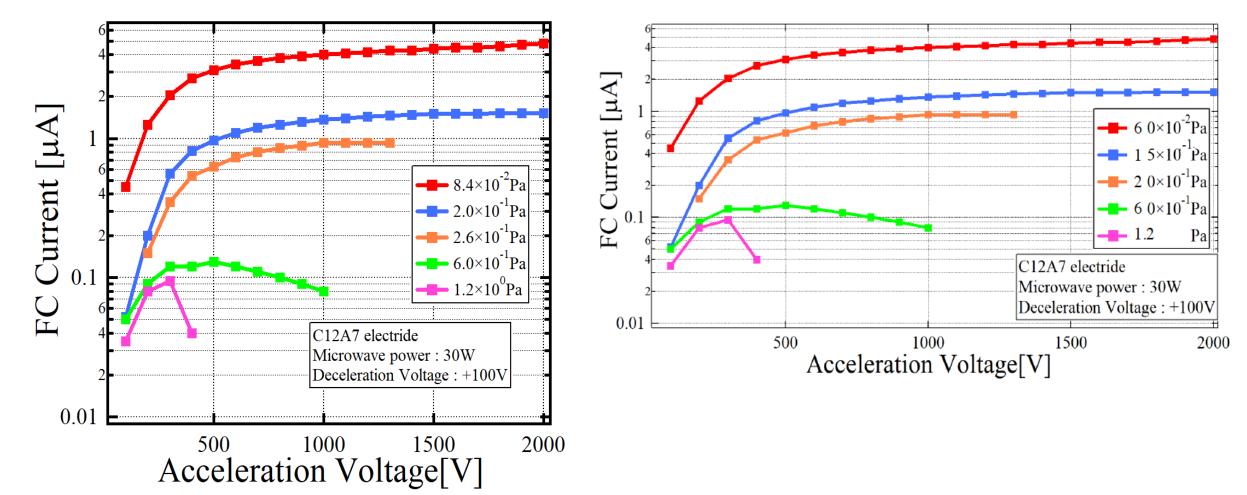




Experimental setup -ion source

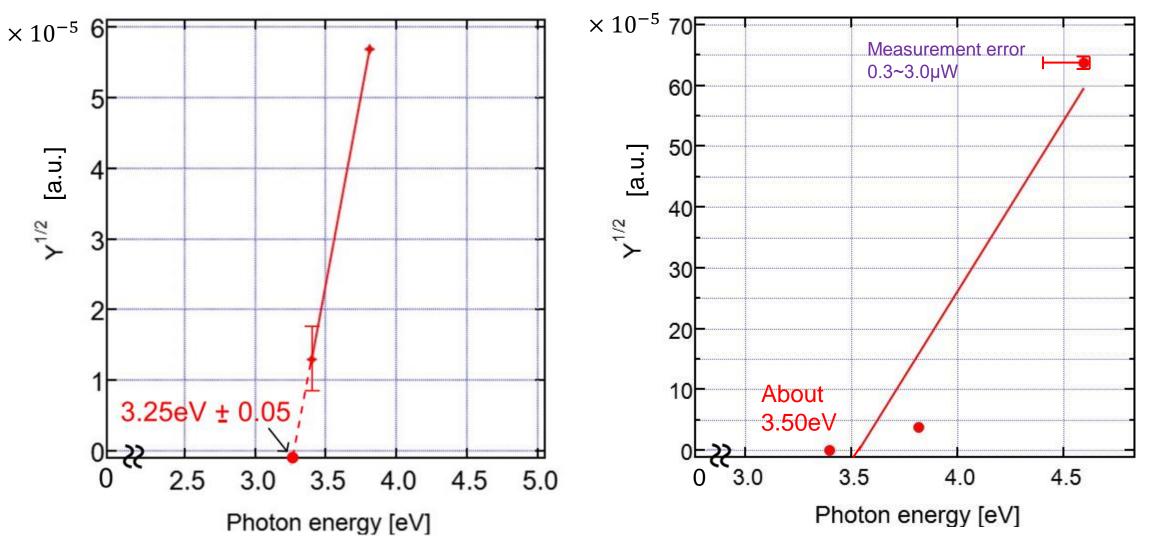
After correction

Before correction



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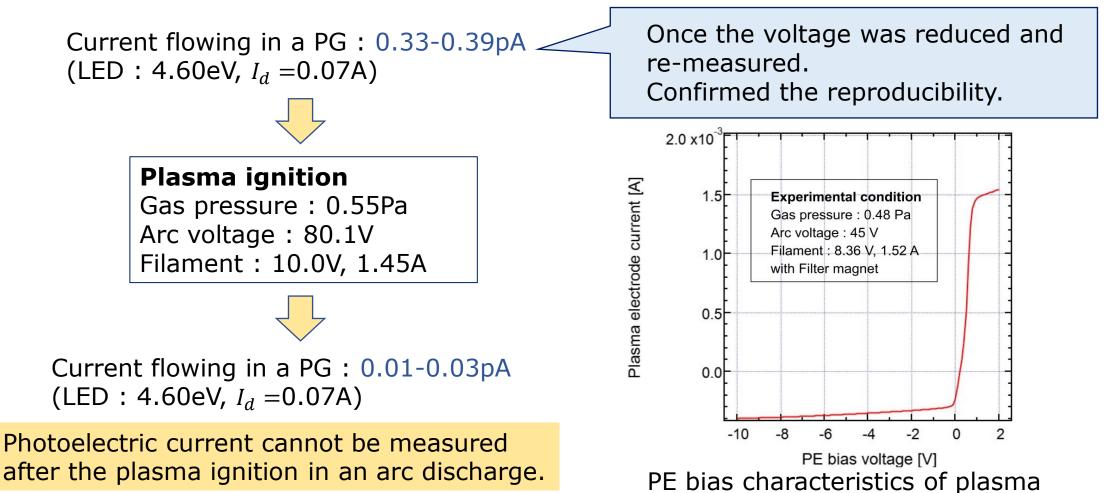
Results –LED based photoelectric current measurement



Comparison of square root of the Quantum Efficiencies of LEDs and Laser.

Results -Change of surface condition by hydrogen plasma exposure realized with a tungsten hot cathode

The photoelectric current measurement using a LED light (270nm).



electrode current.

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Summary and outlook

- The work function of electride has been measured successfully using LEDs.
- New ion source, equipped with large window for LED light injection was assembled and being tuned.
- Tungsten filamen may contaminate electride PG surface to increase the work function. (to be confirmed)
- Need to increase of the number of wavelengths of LEDs (275nm, 310nm) used for photoelectric current measurement.
- Experiment with 2.45 ECR to compare the result with W filament discharge.
- Confirmation of Cs/Mo work function with LEDs.

Thank you for your attention!